



*THW*  
**PATENT**

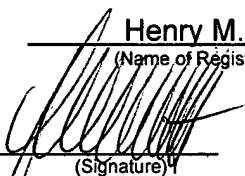
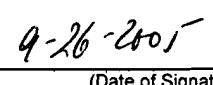
**THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Docket No.: WOLFF-4

In re Application of:	)
THOMAS WOLFF	)
Appl. No.: 10/693,771	) Examiner: Chen, Eric Brice
Filed: October 24, 2003	) Group Art Unit: 1765
For: METHOD AND DEVICE FOR PHOTO-ELECTRONICALLY ETCHING A SEMICONDUCTOR SAMPLE, ESPECIALLY GALLIUM NITRIDE	)

**RESPONSE TO OFFICIAL ACTION**  
**dated July 22, 2005**

MAIL STOP AMENDMENT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450  
S I R:

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on <b>September, 26, 2005.</b>	
(Date)	
 Henry M. Feiereisen (Name of Registered Representative)	 (Date of Signature)

This communication is in response to the Official Action of July 22, 2005, having a shortened period for response terminating October 24, 2005.

The Commissioner is hereby also authorized to charge any fees which may be required during the pendency of this application, including any patent application processing fees under 37 C.F.R. 1.17, and any filing fees under 37 C.F.R. 1.16, including presentation of extra claims, or credit any overpayment to Deposit Account No: 06-0502.

Please amend the above-entitled application as follows: